

Serial No.: 09/891,833



<u>Patent</u>

In Re Application of	of:)		
Steven Verh	naverbeke et al.)		
U.S. Serial No:	09/891,833)	Examiner:	Kristen C. Jolley
Filed:	June 25, 2001)	Art Unit:	1762
For: METHOD A FOR CHEMICAL I WAFER PROCESS Commissioner for P.O. Box 1450 Alexandria, VA 22	Patents	,		
	AMENDMI	ENT ANI	O RESPONSI	<u> </u>
Dear Sir:				
This is in res	sponse to the Offic	e Action	mailed Octob	er 16, 2003. Applicant
respectfully reques	sts the Examiner to	enter the	e following ar	nendments and consider
the following rema	ırks.			
	FIRST CLASS	CERTIFICA	TE OF MAILING	
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I hereby certify that this of sufficient postage in an er COMMISSIONER FOR P U.S. Patent and Tradema	nvelope addressed to M. ATENTS, P.O. Box 1450,	AIL STOP _ . Alexandria	, VA 22313-1450	tes Postal Service as first class mail with y 16, 2004 Date of Deposit
Tere	sa Edwards			(
Nam	e of Person Mailing Cor	respondence	9	•
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Signa	ature		0	Date'

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Attorney Docket: 4730USA/W-C/W-C/JB1 BSTZ Reference: 04887P451